

11046 U.S. PTO  
10/081285  
02/20/02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Takenori Hirose, et al.

Application No.:

Filed: Herewith

For: Film Thickness Measuring  
Method and Apparatus, and Thin Film  
Device Manufacturing Method and  
Manufacturing Apparatus Using Same

Examiner: Unassigned

Art Unit: Unassigned

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §1.97 and §1.98

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

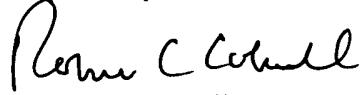
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Page +

PATENT

Respectfully submitted,



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PTO/SB/08A (08-00)

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

1 of 1

**Complete if Known**

Application Number

Filing Date

First Named Inventor

Hirose, Takenori

Group Art Unit

Examiner Name

Attorney Docket Number

16869P-042900US

P10  
S.1386  
J.081386  
110416  
10/10/02  
02/20/02

### U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
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### FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
	AU	JP	2000-241126		Nikon Corp.	09-08-2000		Abstract
	AV	JP	2000-009437		Hitachi, Ltd.	01-14-2000		Abstract
	AW	JP	09-193995		Kanebo, Ltd.	07-29-1997		Abstract
	AX	JP	09-109023		Nova Measuring Instr., Ltd.	04-28-1997		Abstract
	AY	JP	09-007985		Applied Materials	01-10-1997		Abstract
	AZ	JP	06-252113		Matsushita Electric	09-09-1994		Abstract
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